



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Isamu Kobori, et al. Art Unit : 2822
Serial No. : 10/713,275 Examiner : Kiesha L. Rose
Filed : November 17, 2003
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF
MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM
TRANSISTOR

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF MAY 22, 2005

Please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims, which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.

An abstract is provided at page 8 of this paper.

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